

 <p>LIST OF REFERENCES CITED BY APPLICANT (Use additional sheets if necessary)</p>				ATTY. DOCKET NO.		APPLICATION NO.	
				11042-005		10/081,768	
				APPLICANT			
				Chen et al.			
FILING DATE				GROUP			
February 22, 2002				1762			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	AF						
	AG						
	AH						
	AI						
	AJ						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
7	AK	Boonekamp et al., Adsorption of Nanometer-Sized Palladium Particles on Si(100) Surfaces, 10 Langmuir 4089-4094 (American Chemical Society, 1994).					
7	AL	Hidber et al., Microcontact Printing of Palladium Colloids: Micron-Scale Patterning by Electroless Deposition of Copper, 12 Langmuir 1375-80 (American Chemical Society, 1996).					
7	AM	Hidber et al., New Strategy for Controlling the Size and Shape of Metallic Features Formed by Electroless Deposition of Copper: Microcontact Printing of Catalysts on Oriented Polymers, Followed by Thermal Shrinkage, 12 Langmuir 5209-5215 (American Chemical Society, 1996).					
EXAMINER <i>Arthur Barr</i>				DATE CONSIDERED <i>12/29/03</i>			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							